

#3

1753



35.C15382

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: Not Yet Assigned
TAKAHARU KONDO ET AL.)	
	:	Group Art Unit: 1753
Application No.: 09/866,665)	
	:	
Filed: May 30, 2001)	
	:	
For: SILICON-TYPE THIN-FILM)	
FORMATION PROCESS,	:	
SILICON-TYPE THIN FILM, AND)	
PHOTOVOLTAIC DEVICE	:	August 22, 2001

Commissioner for Patents
Washington, D.C. 20231

RECEIVED
AUG 27 2001
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INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

For the concise explanation of relevance for the non-English document the Examiner is referred to the English abstract, and to page 1 of the present specification.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicants

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